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PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10041609	01/10/2002	438		2818	K. M. LEE

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**CONTINUING DATA VERIFIED:

THIS APPLICATION IS A DIV OF 09/102,665 06/23/1998 PAT 6,349,669
WHICH IS A DIV OF 08/924,304 09/05/1997 PAT 6,069,094

** FOREIGN APPLICATIONS VERIFIED:

JAPAN 8-257675 09/06/1996

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>	
Foreign priority claimed 35 USC 119 conditions met Verified and Acknowledged Examiner's initials		<input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> yes <input type="checkbox"/> no	ATTORNEY DOCKET NO 971003B
TITLE : Method and apparatus for depositing a thin film, and semiconductor device having a semiconductor-insulator junction			

NOTICE OF ALLOWANCE MAILED		Assistant Examiner	CLAIMS ALLOWED	
			Total Claims	Print Claim for O.G.
ISSUE FEE		DRAWING		
Amount Due	Date Paid	Sheets Drwg.	Figs.Drwg.	Print Fig.
TERMINAL DISCLAIMER		Application Examiner		
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